



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

August 14, 2026	
IGI Report Number	LG828648008
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	11.70 X 8.00 X 4.85 MM

GRADING RESULTS

Carat Weight	2.84 CARATS
Color Grade	E
Clarity Grade	VS 1

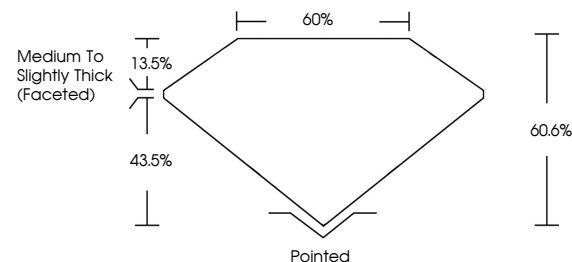
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG828648008

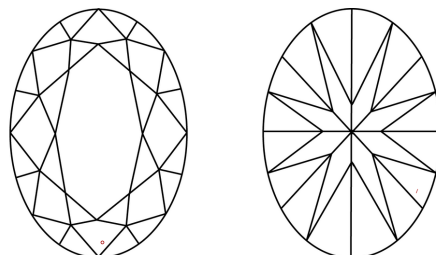
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG828648008
Report verification at lgi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

August 14, 2026	2.84 CARATS
GI Report No. LG828648008	VS 1
CLAY BRILLIANT	60.6%
	60%
1.70 X 8.00 X 4.86 MM	Medium to Slightly Thick (Faceted)
Carat Weight	Ported
Color Grade	EXCELLENT
Clarity Grade	EXCELLENT
Depth	NONE
Table	681 LG828648008
Gable	
Fluorescence	
Inscriptions(s)	
Quiet	
Polish	
Symmetry	
Comments:	
Chemical Vapor Deposition was created by	
CVD growth process.	
Type IIA	